U.S. Patent Application Serial No. 09/669,448
Attorney Docket No.: 001241

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: HIROYAMA, Ryouji et al.

Group Art Unit: 2815

Serial No.: 09/669,448

Examiner: Matthew C. Landau

Filed: September 25, 2000

P.T.O. Confirmation No.: 2968

SEMICONDUCTOR LASER DEVICE AND METHOD OF MANUFACTURING THE For:

SAME

SUPPLEMENTAL AMENDMENT UNDER 37 CFR §1.111

Commissioner for Patents Washington, D.C. 20231

March 19, 2003

Sir:

In further response to the Office Action dated September 12, 2002, please amend the aboveidentified application as follows:

IN THE CLAIMS:

Amend claims 1 and 4 as indicated below:

1. (Twice Amended) A semiconductor laser device comprising:

28UD MAIL ROOM

a substrate;

a first conductivity type cladding layer;

an emission layer;